TRA		OSURE STATEMEIN I` 7(c))	Docket No. S111-USA						
In Re Application Of: Greenberg, et al.									
	Serial No.	Filing Date	Examiner	Group Art Unit					
	10/ 064 ,458	10/26/2001	unknown	unknown					
Title:	IMPLANTABLE	MICROFLUIDIC DELIVERY S'	YSTEM USING ULTRA-NANOCR	RYSTALLINE DIAMOND					
COAT	ING								
	Address to: Assistant Commissioner for Patents Washington, D.C. 20231								
		37 C	CFR 1.97(b)						
1. 🛚	The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.								
			CFR 1.97(c)						
2.	The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:								
	☐ the staten	ment specified in 37 CFR 1.97(e):	; ;	•					
	·	OR							
	☐ the fee se	et forth in 37 CFR 1.17(p).							

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(Data)	ice (F	Certificate of Mailing by First Class Mail I certify that this document and fee is being deposited March 7,2002 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington D.C. 20231.	
(Date)		A	
	Signature	Signature of Person Mailing Correspondence Emily M. Stuart	
Typed or Printed Nam	ne of Person Signing Certificate	Typed or Printed Name of Person	on Mailing Certificate
Juny Mr		Dated: 3/7/02_	

Application Number 5 10/061,458 Locket Number (Optional) **S11** INFORMATION DISCLOSURE CITATION Applicant(s) Greenberg, et al. (Use several sheets if necessary) Filing Date Group Art Unit 10/26/01 unknown 2.3 U.S. PATENT DOCUMENTS: EXAMINER FILING DATE DOCUMENT NUMBER DATE CLASS SUBCLASS NAME INITIAL IF APPROPRIATE 4,991,582 2/12/91 Byers, et al. 5,750,926 5/12/98 Schulman, et al. 5,797,898 8/25/98 Santini, Jr. et al. 6,123,861 9/26/00 Santini, Jr. et al. FOREIGN PATENT DOCUMENTS Translation REF DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

D.M. Zhou, et al., "Accelerated Corrosion Tests on Silicon Wafer for Implantable Medial Devices", Proc. of 198th Electrochemical Society Meeting, 363, October 2000

D.M. Gruen, "Nanocrystalline Diamond Films" Annu. Rev. Mater. Sci., 29 211-59 (199)

EXAMINER DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

		Docket Number (Optional)	Application Number				
		S11	10/046458				
INFO	DRMATION DISCLOSURE CITATION (Use several sheets if necessary)	Applicant(s) Greenberg, et al.					
		Filing Date 10/26/2001	Group Art Unit unknown				
*EXAMINER INITIAL		OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)					
INITIAL	D.M. Gruen, et al. "Buckyball Microwave Plasm	mas: Fragmentation and Diamond F	Film Growth", J. Appl. Phys., 75 (3)				
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